



FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. 35.C15518	APPLICATION NO. 09/895,464
		APPLICANT Tohru Den et al.	
		FILING DATE July 2, 2001	GROUP N.Y.A.

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<i>KL</i>	6,214,738B1	04/10/01	Aiba et al.	438	707		
<i>KL</i>	6,139,713	10/31/00	Masuda et al.	205	206		

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
<i>KL</i>	JP 11-224422	08/17/99	Japan			Abstract	
<i>KL</i>	JP 10-121292	05/12/98	Japan			Abstract	

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
<i>KL</i>	Hideki Masuda et al., "Fabrication of a One-Dimensional Microhole Array by Anodic Oxidation of Aluminum," 63(23) Appl. Phys. Lett. 3155-3157 (1993).
↓	H. Masuda, 31(5) Solid State Physics 493-499 (1996).
↓	R.C. Furneaux et al., "The Formation of Controlled-Porosity Membranes From Anodically Oxidized Aluminum," 337 Nature 147-149 (1989).
<i>KL</i>	Hideki Masuda et al., "Fabrication of Gold Nanodot Array Using Anodic Porous Alumina as an Evaporation Mask," 35(2) Jpn. J. Appl. Phys. 35(2) L126-L129 (1996).

EXAMINER <i>Krupa D. Smith</i>	DATE CONSIDERED 12/18/01
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		ATTY DOCKET NO. 35.C1557B	APPLICATION NO. 09/895,464
		APPLICANT AUG 0 3 2001	Tohru Den et al.
		FILING DATE AUG 03 2001	GROUP N.Y.A.

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
72	EP	0913508A2	05/06/9	EPO			
	EP	0951047A2	10/20/9	EPO			
	JP	11-194134	07/21/9	Japan			Abstract
	JP	2000-31462	01/28/0	Japan			Abstract
	JP	11-139815	05/25/9	Japan			Abstract
72	JP	11-200090	07/27/9	Japan			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		

EXAMINER Kevin Quinlan	DATE CONSIDERED 12/8/03
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